

9A4 2824

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. YOR920010499US1 (14710)	
Re Application Of: Stephen W. Bedell, et al.				
Serial No. 10/055,138	Filing Date 1/23/2002	Examiner Pho M. Luu	Group Art Unit 2824	
Title: METHOD OF CREATING HIGH-QUALITY RELAXED SiGe-ON-INSULATOR FOR STRAINED Si CMOS APPLICATIONS				
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450				
37 CFR 1.97(b)				
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.				
37 CFR 1.97(c)				
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:				
<input type="checkbox"/> the statement specified in 37 CFR 1.97(e);				
OR				
<input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).				

RECEIVED
JUL 11 2003
GROUP 1700

RECEIVED
JUN - 8 2003
TECHNOLOGY CENTER 2800

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.

0920010499 (14710)

JUL 03 2003

In Re Application:

Stephen W. Bedell, et al.

Serial No.

10/055,138

Filing Date

1/23/2002

Examiner

Pho M. Luu

Group Art Unit

2824

METHOD OF CREATING HIGH-QUALITY RELAXED SiGe-ON-INSULATOR FOR STRAINED Si CMOS APPLICATIONS

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of _____ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. **50-0510/IBM** as described below.
- ☐ Charge the amount of _____
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.

Certificate of Transmission by Facsimile*

I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (F:

(Date)

Signature

Typed or Printed Name of Person Signing Certificate

Certificate of Mailing by First Class Mail

I certify that this document and fee is being deposited on **6/30/2003** with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

Leslie S. Szivos, Ph.D.

Typed or Printed Name of Person Mailing Certificate

*This certificate may only be used if paying by deposit account.

Leslie S. Szivos
Signature

Dated: June 30, 2003

Leslie S. Szivos, Ph.D.

Registration No. 39,394

SCULL, SCOTT, MURPHY & PRESSER

400 Garden City Plaza

Garden City, New York 11530

(516) 742-4343

CC:



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Stephen W. Bedell, et al.

Examiner: Pho M. Luu

Serial No: 10/055,138

Art Unit: 2824

Filed: January 23, 2002

Docket: YOR920010499US1 (14710)

For: METHOD OF CREATING
HIGH-QUALITY RELAXED
SiGe-ON-INSULATOR FOR STRAINED
Si CMOS APPLICATIONS

Dated: June 30, 2003

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

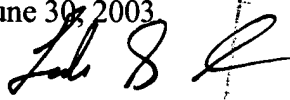
Sir:

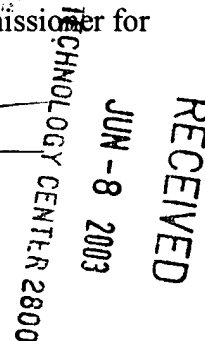
In accordance with 37 C.F.R. §1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450 on June 30, 2003.

Dated: June 30, 2003


Leslie S. Szivos, Ph.D.



The references were cited in a Search Report received from the U.S. Patent Office dated June 4, 2003. Applicants are submitting copies of the cited references, together with a copy of the Search Report. The relevance of the above-identified references has been described in the Search Report.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. § 1.97(b), no statement or fee is required.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'LSZ', with a long horizontal flourish extending to the right.

Leslie S. Szivos, Ph.D.
Registration No. 39,394

SCULLY, SCOTT, MURPHY & PRESSER
400 Garden City Plaza
Garden City, New York 11530
(516) 742-4343

LSS/sf
Enclosures PTO 1449
Two (2) References